

PATENT  
Attorney Docket  
542-007-4

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: Matsubara

Serial No.: To be assigned

Filed: herewith

Title: METHOD FOR MANUFACTURING TFT ARRAY SUBSTRATE OF LIQUID CRYSTAL DISPLAY DEVICE

Assistant Commissioner for Patents  
Washington, D.C. 20231

H. P. a  
S. Septe  
2-6-03

Dear Sir:

Kindly enter the following Amendment and Remarks in this application before examination.

PRELIMINARY AMENDMENT

In the claims:

Please amend claims 4 through 14 as follows:

4. A method for manufacturing a TFT array substrate according to claim 1 wherein a ITO film is further formed, and through patterning to selectively remove the ITO film, the ITO film on the source line is left to form the ITO film covering the source line.

*Al Comt*

5. A method for manufacturing a TFT array substrate in which as least (a) a gate insulating film, (b) a semiconductor layer and (c) a metal layer are sequentially formed in this order